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Attorney Docket No.:100806-00215 (NECA 20.494)

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Inventor: Hiroshi OKUMURA  
Serial No.: 10/615,670  
Filed: July 8, 2003  
Title: **METHOD OF FORMING SEMICONDUCTOR THIN-FILM  
AND LASER APPARATUS USED THEREFORE**  
Examiner: Samuel M. Heinrich  
Group Art Unit: 1725

Mail Stop Amendment  
Commissioner for Patents  
P. O. Box 1450  
Alexandria, VA 22313-1450

AMENDMENT

SIR:

In response to the Office Action mailed on February 7, 2005, the period for responding thereto having been set to expire after May 7, 2005, please amend the above-captioned application as follows: